



566.40319X00
Response Under 37 CFR 1.116
Expedited Procedure
Group No. 2813

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: T. UCHIDA, et al.
Application No.: 09/869,347
Filed: September 7, 2001
For: MATERIALS FOR POLISHING LIQUID FOR METAL,
POLISHING LIQUID FOR METAL, METHOD FOR
PREPARATION THEREOF AND POLISHING METHOD USING
THE SAME
Art Unit: 2813
Examiner: L. M. Schillinger

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11-6-04

REQUEST FOR RECONSIDERATION
AFTER FINAL REJECTION

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 31, 2004

Sir:

In response to the Office Action mailed October 31, 2003, Applicants respectfully request reconsideration of the Final rejection of claims 1-55, under 35 USC §102(e) as being anticipated by the teachings of U.S. Patent No. 5,770,095 to Sasaki, et al., and respectfully submit that all of the claims now presented for consideration by the Examiner patentably distinguish over the teachings of the reference applied by the Examiner in rejecting claims in the Office Action mailed October 31, 2003, that is, the teachings of Sasaki, et al., under the requirements of 35 USC §102 and 35 USC §103.